



Attorney Docket No: TSMC2003-0532
[N1280-00265]

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor Application of: Wei-Lian Lin et al.

Confirmation No.: 6889

Serial No.: 10/748,075

Group Art Unit: 2877

Filed: December 30, 2003

Examiner: Not Yet Assigned

For: **METHOD FOR REPAIRING OPAQUE DEFECTS ON SEMICONDUCTOR MASK
RETICLES**

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